



差压与表压，集成压力传感器（0至**10**千帕）

MPXx5010

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恩智浦MPX5010/MPXV5010G/MP3V5010系列压阻式传感器是先进的单片式硅压力传感器。该传感器应用范围广泛，特别是采用带A/D输入的微控制器或微处理器的应用。该传感器集先进的微机械、薄膜金属化和双极性工艺于一身，可提供与所施压力成正比、精确的高电平模拟输出信号。

MPxx5010_BD Block Diagram

PACKAGING ORDERING INFORMATION			
Device Type	Options	Packaging Options	Case
MPVZ5010GW6U	-	Rails	1735
MPVZ5010GW7U	-	Rails	1560
MPVZ5010G6U	-	Rails	482
MPVZ5010G6T1	-	Tape and Reel	482
MPVZ5010G7U	-	Rails	482B
MPXV5010G6U	Gauge, Element Only, SMT	Rails	482
MPXV5010G7U	Gauge, Element Only, DIP	Rails	482B
MPXV5010GC6U	Gauge, Axial Port, SMT	Rails	482A
MPXV5010GC7U	Gauge, Axial Port, DIP	Rails	482C
MPXV5010GC6T1	Gauge, Axial Port, SMT	Rails	482A
MPXV5010GP	Gauge, Side Port, SMT	Tape and Reel	1369
MPXV5010DP	Gauge, Dual Port, SMT	Trays	1351
MPX5010D	Differential	-	867
MPX5010DP	Differential, Gauge	-	867C
MPX5010GP	Gauge	-	867B
MPX5010GS	Gauge, Axial	-	867E
MPX5010GSX	Gauge, Axial PC Mount	-	867F

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